



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

TAKAYAMA, Toshio, et al.

Group Art Unit: **2811**

Serial No.: **10/735,886**

Examiner: **Nitin PAREKH**

Filed: **December 16, 2003**

P.T.O. Confirmation No.: **5693**

For: **SEMICONDUCTOR DEVICE HAVING A MULTILAYER INTERCONNECTION STRUCTURE AND FABRICATION PROCESS THEREOF**

AMENDMENT UNDER 37 CFR §1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

April 29, 2005

Sir:

In response to the Office Action dated January 14, 2005, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 8 of this paper.